

04/12/01
Jc921 U.S. PTO

04-16-01

A
Docket No. 005651/ETCH/CHMBR/JB1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
Commissioner of Patents and Trademarks
Washington, D.C. 20231

Jc921 U.S. PTO
09/18/2001
04/12/01

Re: Inventor(s): Michael Barnes and David Palagashvili
Title: PLASMA REACTOR ELECTRODE

Transmitted herewith is the patent application identified above, including:

Specification, claims and abstract, totaling 9 pages.

Drawings totaling 2 pages, Formal Informal.

Executed Declaration and Power of Attorney.

Assignment of the invention to **Applied Materials, Inc.**

Assignment Recordation Cover Sheet

Information Disclosure Statement (37 CFR 1.98)

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	16	-20=	0	X\$18.00	\$000.00
Independent Claims	2	-3=	0	X\$80.00	\$000.00
Basic Filing Fee				\$710.00	\$710.00
TOTAL FEES					\$710.00

The Commissioner is hereby authorized to charge \$710.00 to Deposit Account No. 50-1074.

The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.

Please address all future correspondence to:

PATENT COUNSEL
APPLIED MATERIALS, INC.
Legal Affairs Department
P.O. BOX 450A
Santa Clara, CA. 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to Commissioner of Patents and Trademarks, Washington, D.C. 20231

Express Mail Receipt No EL66180502545

Date of Deposit 4-12-2001

Signature Betty Mulcahy

Respectfully submitted,

Robert W. Mulcahy
Registration No. 25,436